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PATENT 450100-02706

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicants** 

Masakazu Hayashi, et al.

Notice of Allowance

Dated: 02/24/2006

Serial No.

09/844,107

Confirmation No. 9971

Filed

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April 27, 2001

For

APPARATUS AND METHOD FOR PROCESSING INFORMATION, AND

PROGRAM AND MEDIUM USED THEREFOR

Examiner

Chuong, Truc T.

Art Unit

2179

745 Fifth Avenue New York, New York 10151

## **FACSIMILE**

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745 Fifth Avenue

New York, New York 10151

## COMMUNICATION REQUESTING GRANT OF PRIORITY CLAIM UNDER 35 USC § 119

Box Issue Fee Assistant Commissioner for Patents Washington, D.C. 20231

The above-referenced application claims priority under 35 USC §119 from a Japanese Application No. 2000-132719 filed in Japan on May 1, 2000. A certified copy of the priority document, Japanese Application No. 2000-132719 was filed with the PTO on September 13, 2001, as evidenced by the postcard return receipt, a copy of which is enclosed. Also

00352449.DOC

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enclosed is a copy of the 1st page of the priority Document. However, the Office has not acknowledged receipt of the above-mentioned document.

The present application is entitled to and should be accorded the right of priority to the May 1, 2000 filing date of the Japanese Application No. 2000-132719.

Respectfully submitted,

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## 日本国特許庁 JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されて いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出願年月日 Date of Application:

2000年 5月 1日

出願番号 Application Number:

特願2000-132719

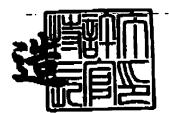
出 顧 人 Applicant(s):

ソニー株式会社

2001年 4月20日

特許庁長官 Commissioner, Japan Patent Office





PAGE 4/4 \* RCVD AT 3/31/2006 3:03:39 PM [Eastern Standard Time] \* SVR:USPTO-EFXRF-5/0 \* DNIS:2738300 \* CSID:12125880500 \* DURATION (mm-ss):00-54